Table 1. PCBs Chemical Decomposition Technology

Cate	Method	Description	PCB	Chemical	Op. Con d.	Company	Basic		ost	Characteristics	App		Starting
gory			Conc.	used	Temp/Pres		Technology	Install	Chem		Tec	Plant	Date
	DMI/NaOH	PCBs are decomposed by NaOH under DMI solvent. Products are Biphenyl and NaCl. Hydrogen source is insulation oil.	High/ Low	NaOH DMI(1,3- dimethyl- 2- imidazolid inon)	200-210 C /Atm	Tokyo Denryoku /Mitsui Co./Neos	Own Process	High	High	-Complicated Process -DMI recovery is key to this process.	Yes L1	U/C	2001 Tokyo Denryoku
ion by Caustics	t-BuOK	2 step reaction; 1 st reaction is catalytically dechlorination by hydrogen under paraffin and 2 nd stage is reaction of PCBs with t- BuOK to produce Kcl and Biphenyl-buthoxide etc.,	High Low	Solvent (Paraffin) H2, N2, Pd/C cat t-BuOK	180-210 C / Atm 200-250 C / Atm	Kansai Tech /Kansai Denryoku	Own Process	High	High	-1 st stage can be applied under 15% PCB concentrationPCB concentration in 2 nd stage should be 200 ppm underCost of t -BtOK is very expensive.	Yes L1	Req.	TBD
Dechlorination reaction	BCD	Dechlorination reaction is taken place under the N2 condition at 300-350 deg C and atm, by adding hydrogen donor, catalyst and caustic to PCBs. Products are Biphenyl; it's derivative, inorganic salt and small amount of water.	High/ Low	NaOH or KOH, Hydro- carbon, catalyst	300-350 C / Atm	Ebara	Licensed from USA	High	Low	-High reaction temperature may cause of fire. -Very difficult to control operation temperature.	Yes L1	Yes	2000 Ebara
	SD	Dechlorination occurs by Dispersed Sodium at low temperature and atmospheric condition. Good reactivity. Products are Biphenyl etc.	High Low	Na dispersed Na dispersed/ Activated agents	160-170 C / Atm 50-60 C / Atm	Nihon Soda/ Ito Chu	Own Process	Low	Med.	-Low Reaction TempSimple ProcessOil product is easily separatedNa is produced by himself.	Yes L1	Yes	2000 Nihon Soda /Tohoku & Hokuriku Denryoku

Cate	Method	Description	PCB	Chemical	Op. Con d.	Company	Basic		ost	Characteristics		roval	Starting
gory			Conc.	used	Temp/Pres		Technology	Install	Chem		Tech	Plant	Date
	OSD	Dechlorination occurs by	High/	Na	80-140 C	Nuclear	Licensed	Low	High	-Low reaction temp.	Yes	Yes	
		Dispersed Sodium at low	Low	dispersed	/ Atm	Fuel Ind.	from			-Simple process.			1999
S ₂		temperature and atmospheric				Ltd./Sum	Canada (Ontario			-High cost Na,	L1		Sumitomo Denko
tic		condition.				itomo	Hydro			imported from			Deliko
austics		Good reactivity.				Corp/Su	Technology)			Canad a.			
చ్		Products are Biphenyl etc.				mitomo Denko							
þ	SP	Dechlorination occurs by	High	Na	120-190 C	Shinko	Licensed	Low	High	-Low reaction temp.	Yes	No	TBD
	51	Dispersed Sodium at low	Ingn	dispersed	/Atm	Pantec	from	LOW	Ingn	-Simple process.	103	140	IDD
Reaction		temperature and atmospheric		dispersed	Atm	Tantee	Canada			-High cost Na,	L3		
l ga		condition.	Low	1	90 C/Atm		(Powertech)			imported from	23		
Dechlorination Re		Good reactivity.	Eo.)					Canada			
	UV/Catalyst	PCB and NaOH are solved in	1 st	UV/NaOH	50-60 C	Toshiba	Own	High	Mid.	-Low reaction temp.	Yes	Req.	TBD
at		Hydrogen donor solution, and	React	/IPA	/ Atm		Process			-Rapid reaction.		_	
l :		UV irradiation.	ion							-Complicated process.	L 3		Test
lole		Dechlorination is taken place	2 nd	Pd/C cat	75 C					-Safety for Mercury			plant:
ြဘ		and Cl will be react with	React		/ Atm					lamp			2000
O		NaOH. In 2 nd stage reaction,	ion							-High catalyst cost.			
		PCB remained is											
		dechlorinated by Catalyst to											
		Biphenyl.											

Approval:

Tech --- Approved Level (L) of technology by authority.
 L1: Plantis in operation or construction.
 L3: Bench scale tests have been completed.

Plant --- Status of Construction:

U/C; Under Construction Req.; Requesting

TBD – To Be Determined

L2: Pilot plant test has been completed. L4: Laboratory tests have been completed

Cate	Method	Description	PCB	Chemical	Op. Con d.	Company	Basic	Cost		Characteristics	Approval		Starting
gory			Conc.	used	Temp/Pres		Technology	Install	Chem		Tech	Plant	Date
	Super Critical water(SCW) oxidation	Oxidation reaction by using High Temp/High pressure water(SCW).	Low/ High	Water/ NaOH	380 C / 300 Atm	Organo	Own Process	High	Low	-High pressure and high temperature -Corrosion problem by severe condition.	Yes L2	No	TBD
of PCB	Hot Water Dechlorination	Oxidation reaction by using high temp and high pressure hot water.	Low/ High	Water/ Sodium carbonate	380 C / 270 Atm	MHI (Mitsubishi Heavy Industry)	Licensed from USA	High	Low	-High pressure and high temperature -Corrosion problem by severe condition.	Yes L1	U/C	2000 MHI, Nagasaki
Total Decomposition	Gas phase hydrogen reduction	Reduction by high temperature hydrogen.	Low/ High	Hydrogen	Over 850 C / Atm	Tokyo Boeki/ Nihon Sharyou	Licensed from Canada (Ecological)	High	Low	-High Temperature. -Require H2 generator	Yes L2	No	TBD
	UV/Biodegrad ation	1 st Stage, PCB is decomposed by UV. 2 nd Stage,PCB is decomposed	High	Solvent (IPA) /NaOH/UV	Amb/Atm	JR	Own Process	High	Low	-Long reaction time for both stagesSafety for Mercury	Yes L3	No	TBD
		by Biodegradation	Low	Bacteria	30 C/ Atm					lamp -Bacteria -Treatment of bacteria sludge.			
	Mechano- chemical	Dry grinding PCB with CaO and SiO2 in a ball mil.	Low/ High	CaO, SiO2	Amb/Atm	Tohoku Univ. Saito	Own process	Low	Low	-Low temp/low pressEasy operation -Low Installation and operation cost.	No (U/A) L4	No	TBD

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